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438	542	Subclass	ISSUE CLASSIFICATION
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PATENT NUMBER

U.S. UTILITY Patent Application

O.I.P.E. **PATENT DATE**
AP 702 Sun
SCANNED Q.A.

APPLICATION NO. 09/904360	CONT/PRIOR F.	CLASS 438	SUBCLASS <u>542</u>	ART UNIT 2802 <u>2825</u>	EXAMINER <u>Fay</u> <u>M. S. G.</u>
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APPLICANTS

Giuseppe Curello
Jürgen Fäßl

TIME

Process for producing a doped semiconductor substrate

PTO-2040
12/99

BEST AVAILAB

<input type="checkbox"/> TERMINAL DISCLAIMER		DRAWINGS			CLAIMS ALLOWED	
		Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims	Print Claim for O.G.
<input type="checkbox"/> The term of this patent subsequent to _____ (date) has been disclaimed.					NOTICE OF ALLOWANCE MAILED	
<input type="checkbox"/> The term of this patent shall not extend beyond the expiration date of U.S Patent. No. _____ _____ _____		(Assistant Examiner) _____ _____ _____				
<input type="checkbox"/> The terminal _____ months of this patent have been disclaimed.		(Primary Examiner) _____ _____ _____			ISSUE FEE Amount Due _____ Date Paid _____	
					ISSUE BATCH NUMBER _____ / _____ Instruments Examined _____ (Date)	

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